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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of *OPE*

MIZUHARA et al.

Serial No.: 09/037,674

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For: "SEMICONDUCTOR DEVICES
PASSIVATION FILM"

Assistant Commissioner for Patents
Washington, D.C. 20231

Group Art Unit: 2814

Examiner: To be assigned

SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT



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BY: *Aimee Shurek* SHERIDAN ROSS P.C.

Dear Sir:

Pursuant to Applicants' duty of disclosure under 37 CFR § 1.56, Applicants hereby submit this Supplemental Information Disclosure Statement with a copy of the documents identified on the enclosed PTO Form 1449, although Applicants do not admit that any of such documents, alone or in any combination, is considered to be material to patentability as defined in 37 CFR § 1.56(b). Moreover, the inclusion of these documents is not to be construed as an admission by Applicants that each such document is prior art as to the above-identified patent application.

Respectfully submitted,

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